



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of)
Yoshiaki HASEGAWA et al.) Art Unit: 2812
Serial No. 09/993,771)
Filed: November 27, 2001) Examiner: Mulpuri, Savitri
For: METHOD FOR MANUFACTURING)
SEMICONDUCTOR AND METHOD)
FOR MANUFACTURING)
SEMICONDUCTOR DEVICE)

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AMENDMENT

Honorable Commissioner of Patents
Washington, D.C. 20231

Sir:

The following is presented in response to the Office Action mailed December 20,
2002, in connection with the above-identified patent application. Please amend the above
identified patent application as follows:

04/14/2003 RMEBRAHT 00000045 09993771

01 FC:1251

110. 0P

04/18/2003 ASMITH 00000003 192380 09993771
01 FC:1201 168.00 CH